| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|----------|------|---|---|---------------------|---------|------------------|
| S19 1 | 40 | (ceramic with (heater or susceptor)) and ((backside adj contamination) or (dechuck\$3 or (de adj chuck\$3))) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 00:31 |
| S19 2 | 31 | (ceramic with (heater or susceptor)) and (backside near3 contamination) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 00:42 |
| S19 4 | 16 | ((backside near3 contamination) with reduc\$4) and (barrier adj layer) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 00:46 |
| S19 5 | 61 | ((backside near3 contamination) with reduc\$4) and ((method or process) same (process\$3 with substrate)) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 00:47 |
| S19 6 | 1 | ((backside near3 contamination) with reduc\$4) and ((method or process) same (process\$3 with substrate)) and season\$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 00:50 |
| S19 7 | 14 | (contamination with reduc\$4) and ((method or process) same (process\$3 with substrate)) and (protect\$3 near3 coat\$3) and (ceramic near3 (heater or susceptor)) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 01:02 |
| S19 9 | 22 | (ruthenium adj silicide) and resistivity | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 01:06 |
| S20 5 | 248 | heater with substrate with ceramic with protect\$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 01:20 |
| S20 6 | 133 | heater with substrate with ceramic with (protect\$3 adj layer) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 01:21 |
| S20 7 | 36 | (heater near3 substrate near3 ceramic) with (protect\$3 adj layer) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:29 |
| S20 8 | 369 | (silic\$2 adj protect\$3 adj (coat\$3 or layer)) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:30 |

| S20 9 | · 342 | ((silic\$2 near2 (protect\$3 adj (coat\$3 or layer))) same (surface)) and contaminat\$3 | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:31 |
|----------|-------|--|---|-----|----|------------------|
| S21 0 | 134 | ((silic\$2 near2 (protect\$3 adj (coat\$3 or layer))) same (surface)) and contaminat\$3 and (deposit\$3 with metal) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:32 |
| S21 1 | 94 | ((silic\$2 near2 (protect\$3 adj (coat\$3 or layer))) same (surface)) and contaminat\$3 and (deposit\$3 with metal) and ((vapor adj deposit\$3) or \$3cvd) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:33 |
| S21 3 | 21 | ((\$4silicon near2 ((protect\$3 or \$3condition\$3 or \$3season\$3) adj (coat\$3 or layer))) same (chamber near3 surface)) and ((vapor adj deposit\$3) or \$3cvd) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:42 |
| S21 4 | 173 | ((\$4silicon with ((protect\$3 or \$3condition\$3 or \$3season\$3) adj (coat\$3 or layer))) same (chamber with (surface or wall or heater or susceptor or electrode or chuck))) and ((vapor adj deposit\$3) or \$3cvd) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:45 |
| S21 5 | . 19 | (((\$4silicon not (silicon with (oxide or oxynitride or nitride))) with ((protect\$3 or \$3condition\$3 or \$3season\$3) adj (coat\$3 or layer))) same (chamber with (surface or wall or heater or susceptor or electrode or chuck))) and ((vapor adj deposit\$3) or \$3cvd) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:48 |
| S21 7 | 3915 | (\$4silicon not (silicon with (oxide or oxynitride or nitride or carbide))) with ((protect\$3 or \$3condition\$3 or \$3season\$3) adj (coat\$3 or layer)) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:49 |
| S21 8 | 521 | S217 with (poly or amorphous) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:50 |
| S21 9 | 407 | S218 and (chamber or wall or susceptor or heater or surface) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:50 |

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|----------|------|--|---|-----|----|------------------|
| S22 0 | 103 | S218 and (chamber or wall or susceptor or heater or surface) and ((vapor adj deposit\$3) or \$3cvd) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:54 |
| S22 2 | 1213 | (barrier adj layer with deposit\$3) same (chamber or apparatus) same (wall or surface) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:55 |
| S22 3 | 20 | S222 same (polysilicon or ((poly or amorphous or alpha) adj silicon)) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 13:58 |
| S22 5 | 183 | (protective adj coating) with ((non adj metal) or silicon) with surface with layer | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 14:00 |
| S22 6 | 82 | S225 and ((vapor adj deposit\$3) or \$3cvd) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 14:09 |
| S23 3 | 963 | (diffusion near1 barrier) with ((\$3season\$3 or protect\$3 or \$3condition\$3) near3 (layer or coat\$3)) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 14:14 |
| S23 4 | 810 | (diffusion near1 barrier) with ((\$3season\$3 or protect\$3 or \$3condition\$3) near2 (layer or coat\$3)) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 14:14 |
| S23 5 | 486 | (diffusion near1 barrier) with ((\$3season\$3 or protect\$3 or \$3condition\$3) near2 (layer or coat\$3)) and ((vapor adj deposit\$3) or \$3cvd) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/20 14:14 |
| S23 7 | 29 | (\$2ald or (atomic adj layer adj deposit\$3)) same (rusi or rusix or "rusi.sub.x" or (ruthenium near1 silicide) or (ru near1 si) or siru) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/21 12:08 |
| S24 0 | 21 | season\$3 with (tungsten or molybdenum) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/21 16:51 |
| S24 1 | 1140 | (ruthenium with deposit\$3) same ((vapor adj_deposit\$3) or \$3cvd) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/21 16:51 |
| S24 3 | 20 | S241 and (particle with contamination) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/21 16:54 |

| S24 7 | 29 | (metal adj silicide) with (barrier adj layer) and backside | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/21 16:59 |
|----------|-----|---|---|-----|----|------------------|
| S24 8 | 16 | (metal adj silicide) with (barrier adj layer) and (backside with (wafer or contamination)) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/21 16:59 |
| S25 1 | 240 | deposit\$3 with silicon with ruthenium and \$3cvd | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/21 17:02 |
| S25 2 | 68 | S251 and (diffusion adj barrier) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/21 19:08 |
| S25 3 | 26 | (rusi or rusix or "rusi.sub.x" or siru or (si near1 ru) or "si/ru") same (\$2ald or (atomic adj layer adj deposit\$3)) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/21 19:09 |

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|----------|------|--|---|---------------------|---------|------------------|
| L5 | 882 | (chromium or cr!) near1 ((vapor adj deposit\$3) or \$3cvd) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/21 19:40 |
| L6 | 31 | I5 and \$4carbonyl | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/21 19:42 |
| L7 | 9 | I5 and (chromium near1 \$4carbonyl) | US-PGPUB; USPAT; EPO; JPO; DERWENT | AND | ON | 2007/12/21 19:42 |